

**PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)
(Large Entity)**Docket No.
AM1562D1In Re Application Of: **YIQIONG WANG**Serial No.
09/882,141Filing Date
June 15, 2001Examiner
Umez-EroniniGroup Art Unit
1765Invention: **METHOD OF ETCHING HIGH ASPECT RATIO OPENINGS IN SILICON****TO THE COMMISSIONER FOR PATENTS:**

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of February 25, 2003 above-identified application.
Date

The requested extension is as follows (check time period desired):

☒ One month ☐ Two months ☐ Three months ☐ Four months ☐ Five months

from: May 25, 2003*Date*until: June 25, 2003*Date*

The fee for the extension of time is \$110 and is to be paid as follows:

- ☐ A check in the amount of the fee is enclosed.
☒ The Director is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account No. 13-4542
☒ If an additional extension of time is required, please consider this a petition therefor and charge any additional fees which may be required to Deposit Account No. 13-4542

BEST AVAILABLE COPY
Signature

Dated: May 29, 2003

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Please continue to send all correspondence to

Patent Counsel, Applied Materials, Inc

PO Box 450A

Santa Clara, CA 95052

I certify that this document and fee is being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature of Person Mailing Correspondence

William R. Morris

Typed or Printed Name of Person Mailing Correspondence

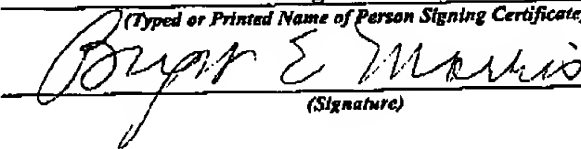
06/03/2003 VAUGBURN 00000002 134542 09882141

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cc: J. Bach

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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)		Docket No.	
Applicant(s): YIQIONG WANG		AM1562D1	
Serial No. 09/882,141	Filing Date June 15, 2001	Examiner Umez-Eronini	Group Art Unit 1765
Invention: METHOD OF ETCHING HIGH ASPECT RATIO OPENINGS IN SILICON			
<div style="text-align: right;">FAX RECEIVED MA 3 0 2003 GROUP 1700</div>			
I hereby certify that this <u>Petition for Extension of time, in duplicate, and fee charged to Deposit Account</u> (Identify type of correspondence)			
is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9310</u>)			
on <u>May 29, 2003</u> (Date)			
<div style="text-align: center;"><u>Birgit E. Morris</u> (Typed or Printed Name of Person Signing Certificate)  (Signature)</div>			
Note: Each paper must have its own certificate of mailing.			
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